

# United States Patent and Trademark Office

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APPLICATION NO.	FILING DATE	PIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFERMATION N
09/182,978	11/05/2001	Kellie L. Dutrs	BRIR920010077	4144
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MCGUIRE WOODS LLP			VINIL	LAN
1750 TYSON				
SUITE 1800			ARTUNIT	PAPER NUMBER
MCLEAN, VA 22102-4215			1765	

DATE MAILED 05/04/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)	
	09/682,978	DUTRA ET AL.	
Office Action Summary	Examiner	Art Unit	
	Lan Vinh	1765	
<ul> <li>The MAILING DATE of this communication</li> <li>Period for Reply</li> </ul>	on appears on the cover sheet w	ith the correspondence addres	s
A SHORTENED STATUTORY PERIOD FOR R THE MALINED DATE OF THIS COMMUNICATI  - Exceptions of time may be available under the provisions of 21 - share SK (t) MOVITH'S them the major date of this communication - If NO period to reply is specified above, the mandrum statutor, - If NO period to reply is specified above, the mandrum statutor, - Failure to epil cywlint this soci or extended portiod for reply with to - Failure to epil cywlint this soci or extended portiod for reply with - The common statutor of	ION. JFR 1 135(a) In no event, however, may a ion i, a reply within the statutory minimum of the period will apply and will expire SIX (6) MO statute, cause the application to become A	reply be timely filed thy (30) days will be considered timely. NTHS from the mailing date of this commu- BANDONED 155 U.S.C. § 133).	nication.
1) Responsive to communication(s) filed on	3/17/2004.		
2a) ☑ This action is FINAL. 2b) ☐	This action is non-final.		
<ol> <li>Since this application is in condition for all closed in accordance with the practice un</li> </ol>			rits is
Disposition of Claims			
<li>4) ☐ Claim(s) 1-26 is/are pending in the applic 4a) Of the above claim(s) is/are with</li>			
<ol><li>Claim(s) is/are allowed.</li></ol>			
6) Claim(s) <u>1-26</u> is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction a	and/or election requirement.		
Annication Paners			

9) The specification is objected to by the Examiner.

10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.

Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).

Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11\sum The eath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

## Priority under 35 U.S.C. §§ 119 and 120

12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).

a) All b) Some c) None of

Certified copies of the priority documents have been received.

Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this National Stage

application from the International Bureau (PCT Rule 17.2(a)).

 See the attached detailed Office action for a list of the certified copies not received. 13\fracknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application)

since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.

a) The translation of the foreign language provisional application has been received.

14\lin Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §\$ 120 and/or 121 since a specific reference was included in the first sentence of the specification or in an Application Data Sheet, 37 CFR 1.78.

Atta	hment(s)
n 🗵	Notice of References Cited (PTO-892)
2) [	Notice of Draftsperson's Patent Drawing Review (PTO-948)
31	Information Disclosure Statement(s) (PTO-1449) Paper No(s)

40 🗆	Interview Summary (PTO-413) Paper No(s).
5)	Notice of Informal Patent Application (PTO-152)
- c	Others

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#### DETAILED ACTION

#### Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(a) the invention was described in (1) an application for patient, published under section 12(b)), by another filed in the United States before the invention by the applicant for patient of 12(b), a patient granted on an application for patient of 12 patient granted on an application for patient by another filed in the United States before the invention by the applicant for patient, occurred that an internal application flore intended in section 351(b) and have the effects for purposes or the succession of an application filed in the United States of 351(b) and have the effects for purposes of the succession of an application filed in the United States and Article 21(b) and Article 21(b)

 Claims 1-7, 9, 11 are rejected under 35 U.S.C. 102(e) as being anticipated by Frankel et al (US 6.444.037)

Frankel discloses an apparatus/chamber for fabricating an integrated circuit. The apparatus/chamber having chamber wall/claimed interior chamber surface, the chamber wall /interior chamber surface comprises of aluminum/claimed a first material, a fluorinebased gas may begin to contaminate or to react with the aluminum chamber wall (col 38, lines 35-45), which reads on a substance incorporated in the first material.

Regarding claims 1-7,9, it is noted that no patentable weight is given to the phrases "the substance balances receipt of a to-be-controlled material", "wherein the interior chamber surface minimizes volatile compound upon a to-be-controlled material contacting the interior chamber surface", "wherein the surface blocks an etching material", "wherein the substance binds with silicon and minimizes Si-F bonding", "wherein the substance minimizes formation of a volatile compound", "wherein the substance minimizes SiF4 formation" and "wherein the substance immedies reaction between the chamber surface and the to-be-controlled material 'because in apparatus, article, and composition claims, a recitation of the intended use of the claimed invention must result in a structural difference between the claimed invention and the prior art in order to patentably distinguish the claimed Invention from the prior art. If the prior art structure/apparatus is capable of performing the intended use, then it meets the claim.

See In re Casey, 152 USPQ 235 (CCPA 1967) and In re Otto, 138 USPQ 458, 459 (CCPA 1963).

Regarding claim 11, Frankel discloses that the chamber is cleaned in a chamber cleaning procedure (col 54, lines 39-41)

3. Claims 13-14, 16, 17 are rejected under 35 U.S.C. 102(e) as being anticipated by Frankel et al (US 6.444,037)

Frankel discloses a method for fabricating an integrated circuit in an apparatus/chamber. This method comprises the steps of: providing an apparatus /chamber 15 having chamber wall/claimed interior chamber surface, the chamber wall /interior chamber surface comprises of aluminum/claimed a first material (col 38, lines 44-46)

performing a seasoning step to recombine all free F species or trapping the species to the chamber wall through silicon oxide deposition, the chamber 15 can trap fluorine atoms that may have been absorbed onto the surfaces of the chamber (col 56, lines 46-48; col 57, lines 23-25), which reads on incorporating a substance in the first material of the interior surface of the reactor chamber with the substance comprising a seasoning

molecule

element or compound containing seasoning atoms or molecules that when combined with the chamber surface and or a material to be used in the reactor chamber are relatively less volatile than a combination, alone without the seasoning atoms or

Regarding claim 14, Frankel discloses placing power residue in the chamber (col 38, lines 39-40), which reads on placing the seasoning element in solid form in the reaction chamber.

Regarding claim 16, Frankel discloses placing SiO2/ power residue in the chamber (col 38, lines 39-40), which reads on a silicon-based compound

Regarding claim 17, Frankel discloses performing additional clean steps after the chamber clean (col 56, lines 17-18)

 Claims 18-20, 22, 23 are rejected under 35 U.S.C. 102(é) as being anticipated by Frankel et al (US 6.444.037)

Frankel discloses a method for fabricating an integrated circuit in an apparatus/chamber. This method comprises the steps of: providing an apparatus /reactor 15 having reactor wall/daimed interior surface of the reactor, the reactor wall /interior surface of the reactor comprises of aluminum/daimed a first material (col 38, lines 44-46)

a fluorine-based gas may begin to contaminate or to react with the aluminum chamber wall to form SiF4 which is drawn out of the chamber (col 38, lines 35-45).

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which reads on incorporated a substance in the first material of the interior surface of the reactor to minimize an undesirable reaction at the surface and to prime the reactor

forming an etched doped dielectric layer/etched product in the reactor (col 42, lines 13-15)

The limitations of claims 19, 20 have been discussed above.

Regarding claim 22, Frankel discloses producing an oxide layer (col 43, lines 55-57)

Regarding claim 23, Frankel discloses performing additional clean steps after the chamber clean (col 56, lines 17-18)

 Claims 24-26 are rejected under 35 U.S.C. 102(e) as being anticipated by Frankel et al (US 6.444.037)

performing a seasoning step to recombine all free F (fluorine) species or trapping the species to the chamber wall through silicon oxide deposition, the chamber 15 can trap fluorine atoms that may have been absorbed onto the surfaces of the chamber (col 56, lines 46-48; col 57, lines 23-25), which reads on incorporating a substance in the first material of the interior surface of the reactor chamber with the substance comprising a seasoning element, the fluorine-based gas can not react with the SiO2 to form SiF4 (col 38, lines 41-43), which reads on reducing the formation of volatile compounds when fluorine encounter the surface

conducting a cleaning step etches native oxide in the reactor using NF3/fluorine gas (col 46, lines 10-54)

The limitation of claim 25 has been discussed above.

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Regarding claim 26, Frankel discloses performing additional clean steps after the chamber clean (col 56, lines 17-18)

### Claim Rejections - 35 USC § 103

 The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness relections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of his title, if the differences between the subject matter sought to be patented and the prior at are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

7. Claim 8 is rejected under 35 U.S.C. 103(a) as being unpatentable over Frankel et al (US 6.444.037) in view of Han et al (US 6.508.911)

Frankel's apparatus/chamber has been described above in paragraph 2. Frankel's apparatus differs from the claimed invention as per claim 8 by comprises of aluminum instead of silicon or SiC.

However, Han, in a method for coating plasma reactor, discloses that coated SiC and SiC/Si composite can be substituted for the aluminum chamber wall (col 9, lines 55-57)

Hence, one skilled in the art would have found it obvious to substitute Frankel's aluminum chamber with SiC in view of Han's teaching because both aluminum and SiC are known material used for the plasma chamber, thus the substitution of one for the other would have produced the expected result. 8. Claims 10, 12, 15, 21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Frankel et al (US 6,444,037) in view of Radhamohan et al (US 5,997,685)

Frankel's method has been described above in paragraph 3. Unlike the instant claimed inventions as per claims 10, 12, 15, Frankel does not specifically disclose the step of including cobalt in the at least one interior chamber surface/ placing cobaltcontaining solid in the chamber.

Radhamohan discloses a method for processing semiconductor substrate using an apparatus comprises the step of using cobalt in the at least one interior chamber surface (col 6, lines 9-11)

Hence, one skilled in the art would have found it obvious to modify Frankel's method by including cobalt in the at least one interior chamber surface/ placing cobaltcontaining solid in the chamber as per Radhamohan because Radhamohan states that additional element such as cobalt provide increase corrosion resistance, thermal shock resistance, or to improve other properties of the alloy used in the chamber (col 6, lines 10-14)

### Response to Arguments

 Applicant's arguments, see the first complete paragraph on page 6 of the response, filed 3/17/2004, with respect to the rejection of claim 18 under 35 USC8 112 have been fully considered and are persuasive. The rejection has been withdrawn.

Applicant's arguments filed 3/17/2004 with respect to the rejection(s) of claims 1-26 have been fully considered but they are not persuasive.

Applicants argue that the combination of various elements recited in claims 1-7. 9. do not include intended use recitation as these claims do not use language that suggest or make optional, thus this claim language should be give patentable weight because according to MPEP & 2106 " the subject matter of a properly construed claim is defined by the term that limit its scope. It is this subject matter that must be examined". This argument is unpersuasive because the MPEP & 2111.03 also recites the following "in apparatus, article, and composition claims, intended use must result in a structural difference between the claimed invention and the prior art in order to patentably distinguish the claimed invention from the prior art. If the prior art structure is capable of performing the intended use, then it meets the claim". Since claims 1-7, 9 of the instant claimed invention are drawn to a reactor/apparatus and the cited prior art of Frankel (US 6,444,037) discloses a fluorine-based gas may begin to contaminate or to react with the aluminum chamber wall of a reactor (col 36, lines 35-45), the examiner asserts that Frankel above-mentioned teaching reads on the claimed limitation of " a substance incorporated in the first material of the interior chamber surface". Thus, Frankel is capable of performing the claimed features of the invention.

The applicants also argue that Frankel removes residues formed on the chamber interior surface and does not add material to produce a less volatile combination. This argument is unpersuasive because as recited in col 58, lines 46-48 of Frankel, Frankel discloses performing a seasoning step to recombine all free F species or trapping the species to the chamber wall through silicon oxide deposition, the chamber 15 can trap fluorine atoms that may have been absorbed onto the surfaces of the chamber. Hence, the examiner asserts that Frankel discloses adding material to the chamber interior surface to produce a less volatile combination

It is argued that Frankel does not teach incorporating a substance in the first material of the interior surface to minimize an undesirable reactor because Frankel only uses a plasma etch. The examiner disagrees because as recited in col 38, lines 35-45, Frankel discloses a fluorine-based gas may begin to contaminate or to react with the aluminum chamber wall to form SIF4 which is drawn out of the chamber which equates to incorporating a substance in the first material of the interior surface to minimize an undesirable reactor.

Applicants further argue that Frankel does not teach seasoning atoms incorporates onto a first material of an interior surface of the reaction chamber. This argument is unpersuasive because in col 56, lines 46-48 and col 57, lines 23-25, Frankel discloses performing a seasoning step to recombine all free F (fluorine) species or trapping the species to the chamber wall through silicon oxide deposition, the chamber 15 can trap fluorine atoms that may have been absorbed onto the surfaces of the chamber (col 56, lines 46-48; col 57, lines 23-25).

 THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not

mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for repty expire later than SIX MONTHS from the mailing date of this final action.

#### Conclusion

 Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lan Vinh whose telephone number is 571 272 1471.
 The examiner can normally be reached on M-F 8:30-5:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on 571 272 1465. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Palent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Vilen

May 27, 2004